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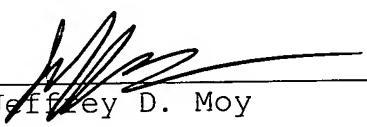
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: YOSHIDA, AKITO DOCKET NO.: W2K1077
SERIAL NO: 10/082,472 EXAMINER: ZARNEKE
FILED: 02/22/2002 ART UNIT: 2829
TITLE: A STACKING STRUCTURE FOR SEMICONDUCTOR DEVICES
USING A FOLDED OVER FLEXIBLE SUBSTRATE AND METHOD
THEREFOR

Mail Stop: Non-Fee Amendment
Commissioner For Patents Weiss, Moy & Harris, P.C.
P.O. Box 1450 4204 North Brown Avenue
Alexandria, VA 22313-1450 Scottsdale, Arizona 85251-3989

March 21, 2005

I hereby certify that on the 21st day of March, 2004,
this correspondence is being deposited with the U.S.
Postal Service as first class mail in an envelope
addressed to: Commissioner for Patents, P.O. Box 1450
Alexandria, VA 22313-1450.



Jeffrey D. Moy

AMENDMENT LETTER

Dear Sir:

This is in response to an Office Communication dated March 2, 2005 dismissing Applicant's Appeal for the above identified patent application and issuing a Restriction Requirement.